

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE
CONVEYING PARTY DATA	
Name	Execution Date
UNIVERSITY OF CHICAGO	12/28/2020
RECEIVING PARTY DATA	
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State/Country:	VIRGINIA
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PROPERTY NUMBERS Total: 1	
Property Type	Number
Application Number:	17082292
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DATE SIGNED:	09/27/2024
This document serves as an Oath/Declaration (37 CFR 1.63).	
Total Attachments: 1	
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Dual Low Vacuum-Ultrahigh Vacuum System for Large-Scale
Invention Title: Production of Micro-Channel Plate Photomultipliers
Andrey Elagin, Evan Angelico, Eric Spieglan, Bernhard Adams,
Inventor(s): Henry Frisch

U.S. Filing/Issue Date: 10/28/2020

Patent or Application Serial No.: 17/082,292

Grant/Contract Number(s): 1707981, DE-SC0015267, DE-SC0008172

Foreign Applications filed/intended in (countries): _____

The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United States Government. This document is confirmatory of:

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The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this 28th day of December, 20 20.

By Jay W. Schrankler
(Institutional Business Official)


(Signature)

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